

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

First  
Named

Inventor: Tinghao F. Wang

Serial No.: 10/071,809

Examiner: Duy Vu Nguyen Deo

Filing

Date: February 7, 2002

Group Art Unit No. 1765

Title: METHOD FOR SELECTIVELY  
ETCHING SILICON AND/OR  
METAL SILICIDES

Confirmation No.: 9444

**TRANSMITTAL**

The following correspondence is being sent electronically to:

M.S. – RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

on

April 27, 2007

Date

Paul E. Rauch, Ph.D., Registration No. 38,591

typed or printed name of person signing Certificate



1. Credit Card Payment (no form included)
2. Request for Continued Examination
3. Amendment and Request for Reconsideration

**Large entity - Payment by credit card.** - The Commissioner is authorized to charge any required fees **not covered by credit card payment** or credit any overpayment to Deposit Account Number 50-3123.

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